



EV633201681

Inventor: **Wei Guo et al.**

Title: **High Purity Nickel/Vanadium Sputtering Components**

Assignee: **Honeywell International Inc.**

Serial No.: **10/720,231**

Filed: **November 25, 2003 [RCE Filed Herewith]**

Client Ref.: **HO004345**

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether the listed references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: _____

1/18/06

By: _____

David G. Latwesen
David G. Latwesen, Ph.D.
Reg. No. 38,533
Wells St. John P.S.

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| Form PTO-1449 | | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | ATTY. DOCKET NO. HO004345 (4016) / HO58-108 | | SERIAL NO. 10/720,231 | |
| LIST OF ART CITED BY APPLICANT <small>(Use several sheets if necessary)</small> | | | | APPLICANT Wei Guo et al. | | | |
| | | | | FILING DATE Nov. 25, 2003 [RCE filed herewith] | | GROUP 1742 | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| *Examiner Initial | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate | |
| | AA | 2,876,180 | 03/59 | Burwell Jr. et al. | | | |
| | AB | 3,294,481 | 12/66 | Burwell | | | |
| | AC | 3,320,024 | 05/67 | Burwell | | | |
| | AD | 4,610,720 | 09/86 | Schmidt et al. | | | |
| | AE | | | | | | |
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| | AK | | | | | | |
| FOREIGN PATENT DOCUMENTS | | | | | | | |
| | Document Number | Date | Country | Class | Subclass | Translation | |
| | | | | | | Yes | No |
| | AL | US03/ 37463 | 11/03 | PCT Search Report | | | |
| | AM | | | | | | |
| | AN | | | | | | |
| OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | |
| | AO | | | | | | |
| | AP | | | | | | |
| | AQ | | | | | | |
| EXAMINER | | DATE CONSIDERED | | | | | |
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